

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Signature

Applicant : I. Kizilyalli, et al.
Application No. : 09/516,004
Filed : February 29, 2000
Title : SELECTIVE LASER ANNEAL ON SEMICONDUCTOR MATERIAL

Grp/Div. : 2811
Examiner : O. Nadav

Docket No. : 45368/MJM/A717

RESPONSE TO FINAL OFFICE ACTION DATED DECEMBER 28, 2001

Box AF
Assistant Commissioner for Patents
Washington, D.C. 20231

Post Office Box 7068
Pasadena, CA 91109-7068
March 28, 2002

Commissioner:

In response to the Final Action of December 28, 2001, and the telephonic Examiner interview which took place on March 5, 2002, applicants offer the following comments in support of the claims of the application as presently presented. Please re-examine the application in view of the remarks provided.

REMARKS

Claims 6-11 are pending in this application, while claims 1-5 and 12-23 have been withdrawn from consideration. Claims 6-11 have each been rejected. Applicants respectfully submit that, in view of the remarks provided, each of pending claims 6-11 is in patentable form as presently presented.